

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 5686**  
Mitsuo SAITO et al. : Attorney Docket No. 2003\_1228A  
Serial No. 10/649,670 : Group Art Unit 1792  
Filed August 28, 2003 : Examiner Allan W. Olsen

PLASMA PROCESSING METHOD AND  
APPARATUS

**Mail Stop: AF**

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**AMENDMENT UNDER 37 CFR 1.116(a)**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action of June 25, 2008, please amend the above-referenced U.S. patent application as follows: